

IAP9 Rec'd PCT/PTO 15 DEC 2009

## INFORMATION DISCLOSURE STATEMENT

FOR	A complex membrane for electrochemical device, manufacturing method and electrochemical device having the same		
Application No.	-	Filing Date	-
Applicant	SAMSHIN CREATION CO., LTD.		
Our Ref.	OV050775US	Your Ref.	-

## U.S. PATENT DOCUMENTS (Not Enclosed)

Document No.	Date	Inventors	U.S. Class	U.S. Subclass	Remark
4,994,335	February 19, 1991	Eiichi et al.			

## FOREIGN PATENT DOCUMENTS

Document No.	Date	Country	Class	Subclass	Translation of Abstract		Remark
					Yes	No	
JP 12-212323 A	August 2, 2000	Japan			x		
JP 14-190291 A	July 5, 2002	Japan			x		

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)


Examiner: /John Maples/  
Signature:Date: 05/14/2010  
Considered:

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /J.M./